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CONFIRMATION NO. 4232

<b>SERIAL NUMBER</b> 09/985,743	<b>FILING OR 371(c) DATE</b> 11/06/2001 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2815	<b>ATTORNEY DOCKET NO.</b> 57810-025	
<b>APPLICANTS</b> Ryosuke Usui, Ichinomiya-shi, JAPAN; Tatsuya Fujishima, Anpachi-gun, JAPAN;  <b>** CONTINUING DATA *****</b>  <b>** FOREIGN APPLICATIONS *****</b> JAPAN JP2000-344754 11/13/2000  <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 01/16/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>myc</u> Examiner's Signature <u>W</u> Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 17	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington, DC20005-3096					
<b>TITLE</b> Semiconductor device having element isolation trench and method of fabricating the same					
<b>FILING FEE RECEIVED</b> 1024	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		